

Electronic Acknowledgement Receipt

EFS ID:	1046031
Application Number:	10650193
Confirmation Number:	6245
Title of Invention:	Semiconductor device having silicon-diffused metal wiring layer and its manufacturing method
First Named Inventor:	Koichi Ohto
Customer Number:	23373
Filer:	Howard Leonard Bernstein/Melissa Patrick
Filer Authorized By:	Howard Leonard Bernstein
Attorney Docket Number:	Q77191
Receipt Date:	12-MAY-2006
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Application Type:	Utility
International Application Number:	

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		Q77191Response.pdf	92765	yes	5

	Multipart Description		
	Doc Desc	Start	End
	Amendment - After Non-Final Rejection	1	1
	Applicant Arguments/Remarks Made in an Amendment	2	5

Warnings:

Information:

Total Files Size (in bytes):

92765

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.